

EAST Search History

EAST Search History (Prior Art)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	94	359/811,819.ccls. and @pd>="20090728"	US-PGPUB; USPAT	OR	ON	2009/11/16 16:42
L2	15	359/815,818,293,298.ccls. and @pd>="20090728"	US-PGPUB; USPAT	OR	ON	2009/11/16 16:42
L3	6	451/42,384.ccls. and @pd>="20090728"	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L4	1000	(project\$3 near2 lens) with imaging with (mask reticle) with (semiconductor semi-conductor substrate)	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L5	2487	(359/811,819).CCLS.	US-PGPUB; USPAT	OR	OFF	2009/11/16 16:43
L6	8	L4 and L5	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L7	1	("20030162484").PN.	US-PGPUB; USPAT	OR	OFF	2009/11/16 16:43
L8	2487	(359/811,819).CCLS.	US-PGPUB; USPAT	OR	OFF	2009/11/16 16:43
L9	0	("(mountinganchoringsupportingholding)near3(lens\$2)"). PN.	US-PGPUB; USPAT	OR	OFF	2009/11/16 16:43
L10	28863	(mounting anchoring supporting holding) near3 (lens\$2)	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L11	25487	project\$4 near5 (exposure lithograph\$5)	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L12	954	L10 and L11	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L13	88	L5 and L12	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43

L14	55	L13 and (glue solder adhesive adhesion adhere)	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L15	1146	359/815,818,293,298.ccls.	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L16	862	451/42,384.ccls.	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L17	25487	project\$4 near5 (exposure lithograph\$5)	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L18	1129704	(glue solder adhesive adhesion adhere)	FPRS; EPO; JPO; DERWENT	OR	ON	2009/11/16 16:43
L19	12335	project\$4 near5 (exposure lithograph\$5)	FPRS; EPO; JPO; DERWENT	OR	ON	2009/11/16 16:43
L20	17667	(mounting anchoring supporting holding) near3 (lens\$2)	FPRS; EPO; JPO; DERWENT	OR	ON	2009/11/16 16:43
L21	3	L18 and L19 and L20	FPRS; EPO; JPO; DERWENT	OR	ON	2009/11/16 16:43
L22	12	L12 and (L15 L16)	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L23	2487	359/811,819.ccls. and @pd>="2008092"	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L24	1146	359/815,818,293,298.ccls. and @pd>="2008092"	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L25	862	451/42,384.ccls. and @pd>="2008092"	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L26	1	("20030162484").PN.	US-PGPUB; USPAT	OR	OFF	2009/11/16 16:43
L27	2487	(359/811,819).CCLS.	US-PGPUB; USPAT	OR	OFF	2009/11/16 16:43

L28	0	("(mountinganchoringssupportingholding)near3(lens\$2)"). PN.	US-PGPUB; USPAT	OR	OFF	2009/11/16 16:43
L29	28863	(mounting anchoring supporting holding) near3 (lens\$2)	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L30	25487	project\$4 near5 (exposure lithograph\$5)	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L31	954	L29 and L30	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L32	88	L27 and L31	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L33	55	L32 and (glue solder adhesive adhesion adhere)	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L34	1146	359/815,818,293,298.ccls.	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L35	862	451/42,384.ccls.	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L36	25487	project\$4 near5 (exposure lithograph\$5)	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L37	1129704	(glue solder adhesive adhesion adhere)	FPRS; EPO; JPO; DERWENT	OR	ON	2009/11/16 16:43
L38	12335	project\$4 near5 (exposure lithograph\$5)	FPRS; EPO; JPO; DERWENT	OR	ON	2009/11/16 16:43
L39	17667	(mounting anchoring supporting holding) near3 (lens\$2)	FPRS; EPO; JPO; DERWENT	OR	ON	2009/11/16 16:43
L40	3	L37 and L38 and L39	FPRS; EPO; JPO; DERWENT	OR	ON	2009/11/16 16:43
L41	12	L31 and (L34 L35)	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43

L42	8	L4 and L5	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L43	0	L4 and L15	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L44	242	(project\$3 near2 lens) with imaging with (mask reticle) with (semiconductor semi-conductor substrate) with support	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L45	1	("20050110973").PN.	US-PGPUB; USPAT	OR	OFF	2009/11/16 16:43
L46	1	("20080002170").PN.	US-PGPUB; USPAT	OR	OFF	2009/11/16 16:43
L47	1	(US-20080002170-\$).did.	US-PGPUB	OR	ON	2009/11/16 16:43
L48	1	L4 and L47	US-PGPUB; USPAT	OR	ON	2009/11/16 16:43
L49	7265	projection near2 lens.clm.	US-PGPUB; USPAT	OR	ON	2009/11/16 16:47
L50	868576	semiconductor	US-PGPUB; USPAT	OR	ON	2009/11/16 16:48
L51	321578	semiconductor.clm.	US-PGPUB; USPAT	OR	ON	2009/11/16 16:48
L52	11149	mounting near2 flange.clm.	US-PGPUB; USPAT	OR	ON	2009/11/16 16:49
L53	3815	shear near2 force.clm.	US-PGPUB; USPAT	OR	ON	2009/11/16 16:49
L54	15282	pressure near2 force.clm.	US-PGPUB; USPAT	OR	ON	2009/11/16 16:49
L55	1	49 and 51 and 52 and 53 and 54	US-PGPUB; USPAT	OR	ON	2009/11/16 16:50

EAST Search History (Interference)

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11/ 16/ 2009 4:50:22 PM

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